

PATENT  
2927-0155P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: MIKI, Mitsunori et al Conf.:

Appl. No.: NEW Group:

Filed: October 9, 2003 Examiner:

For: METHOD AND APPARATUS OF MEASURING  
ROTATIONAL AND FLIGHT CHARACTERISTICS OF  
SPHERE

PRELIMINARY AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

October 9, 2003

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

This amendment includes:

Amendments to the Specification

Remarks